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Robert -  
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In re Patent Application of

FUKUMI

Atty. Ref.: 829-590

Serial No. 09/993,897

Group: 2812

Filed: November 27, 2001

Examiner: Roman, Angel

For: SEMICONDUCTOR SUBSTRATE AND METHOD FOR FABRICATING THE  
SAME

\* \* \* \* \*

December 30, 2002

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

AMENDMENT AFTER FINAL

Responsive to the Official Action dated September 30, 2002, please amend the  
above-identified application as follows:

IN THE CLAIMS

Please substitute the following amended claim(s) for corresponding claim(s)  
previously presented. A copy of the amended claim(s) showing current revisions is  
attached.

1. (Amended) A semiconductor substrate device, comprising:

a first semiconductor substrate including a concave-convex surface;

a second semiconductor substrate having a non-glass thin film insulator on a  
surface thereof,